

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10595660
<b>Filing Date:</b>	03-May-2006
<b>Title of Invention:</b>	High purity hafnium, target and thin film comprising said high purity hafnium, and method for producing high purity hafnium
<b>First Named Inventor/Applicant Name:</b>	Yuichiro Shindo
<b>Filer:</b>	William Bak
<b>Attorney Docket Number:</b>	OGOSH53USA

Filed as Large Entity

### **U.S. National Stage under 35 USC 371 Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
-------------	----------	----------	--------	----------------------

**Basic Filing:**

**Pages:**

**Claims:**

**Miscellaneous-Filing:**

**Petition:**

**Patent-Appeals-and-Interference:**

Notice of appeal	1401	1	620	620
------------------	------	---	-----	-----

**Post-Allowance-and-Post-Issuance:**

<b>Extension-of-Time:</b>				
---------------------------	--	--	--	--

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>620</b>